

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Woon-Yong PARK, *et al.*

Art Unit: To be assigned

Application No.: To be assigned

Examiner: To be assigned

Filed: Herewith

Atty. Docket: 6192.0091.D2

For: **PHOTOLITHOGRAPHY METHOD  
FOR THIN FILM (AS AMENDED)**

**Preliminary Amendment**

Commissioner for Patents  
Alexandria, VA 22313

Sir:

Please amend the above-identified patent application as follows.

*Amendments*

***In the Title:***

Please amend the title to read: -- **PHOTOLITHOGRAPHY METHOD FOR THIN FILM** --.

***In the Specification:***

At the beginning of the specification, please enter the following paragraph.

--

**CROSS REFERENCE**